

Application No.: 09/943,955
Docket No.: 5918/FPS/MMCS/APC/DV

PATENT/OFFICIAL

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

SHANMUGASUNDRAM et al.

Serial No. 09/943,955

Filed: August 31, 2001

For: FEEDBACK CONTROL OF CHEMICAL MECHANICAL POLISHING DEVICE
PROVIDING MANIPULATION OF REMOVAL RATE PROFILES



Group Art Unit: 1765

Examiner: L.T. Umez Eronini

*FTT
Record*

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Date:

9/14/04

Janet McKean
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Commissioner for Patents
U.S. Patent and Trademark Office
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AND RESPONSE

Sir:

This Amendment and Response is responsive to an Office Communication dated May 5, 2004, and is accompanied by a petition for two month extension of time to extend the period of response up to and including October 5, 2004. Please amend the above-identified application as follows.

Amendments to the Specification begin on *page 2*.

Amendments to the Claims are reflected in the listing of claims, which begins on *page 5* of this paper.

Remarks/Arguments begin on *page 14* of this paper.

Docket No.: Please change the Attorney Docket No. to: 5918/FPS/MMCS/APC/DV

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